



## **INSTITUTE OF NANO OPTOELECTRONICS RESEARCH AND TECHNOLOGY (INOR)**

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## **MOCVD GROWN SAMPLE REQUEST FORM**

Requestor Name :			
Contact No.	: Email :		Date :
School/Company :			
Category :	INOR Staff/Student Other Dept. :		
Sample Type :	Powder Thin Film	No. of Samp	ole :
Materials :			
Substrate :			
Please Tick Appropriate Box	METAL ORGANIC CHEMICA	L VAPOUR DEPOSITION [MOCV	DI
(run per hour/standard samp	ile)		
- 1 <u>- 1 1                             </u>		Substrate	0.1.1.4.7500
Single layer		C-Plane Flat Sapphire Substrate (FSS)  C-Plane Patterned Sapphire Substrate (PSS)	
Few layers [<5 layers]			
* Please attach the schematic of the planned structure with thickness.			
Expected results [e.ç	g. Indium composition, n-doping, p-doping]:		
Other information about the sample (e.g. sample stability/temperature):			
Requestor Signature	a:	Supervisor Approval:	
110440010. 0.3	"	(if Students, need to get the approval from Superv	visor)

- Remarks:
  \* Please refer to the analysis/equipment usage charges on INOR website.
  \*\* Any incomplete form will not be processed.
  \*\*\* Quotation will be sent through requestor's email within 3 working days.